

Q. Consider a Si PIN diode with an Intrinsic region width of  $w = 20 \mu\text{m}$ . Assume that the photon flux is  $10^{17}/\text{cm}^2/\text{sec}$  & Absorption Coefficient is  $\alpha = 10^3/\text{cm}$ . Then photo current density is : \_\_\_\_\_  $\text{mA}/\text{cm}^2$ ? (2M)

Ans:- Here Examiner Not Specified  $G_L \Rightarrow$  We Can't Consider Uniform generation Rate.

So,  $G_L$  @ front edge of Intrinsic region  $G_{L1} = \alpha \phi_0 = 10^{20}/\text{cm}^3/\text{sec}$ .

$G_L$  @ back edge of Intrinsic region  $G_{L2} = \alpha \phi_0 e^{-\alpha w} = 0.135 \times 10^{12}/\text{cm}^3/\text{sec}$ .

→ For Testing → It clearly shows  $G_L \rightarrow$  Non Uniform Throughout Intrinsic region.

Hence, photo Current density,

$$J_L = q \phi_0 (1 - e^{-\alpha w})$$

$$= (1.6 \times 10^{-19}) (10^{17}) (1 - \exp[-10^3 (20 \times 10^{-4})])$$

$$= 13.8 \text{ mA/cm}^2.$$



Q. Consider GaAs @  $T=300K$ , Assume the photon intensity @ a Particular point is  $I_p(x) = 0.05 W/cm^2$  at a Wave length

(in)  $\lambda = 0.75 \mu m$ . Then the Generation rate of Electron hole pair where intensity is typical of Sunlight is  $\text{---} \times 10^{21} cm^{-3}s^{-1}$  [Let Absorption coefficient for GaAs,  $\alpha \approx 0.9 \times 10^4 / cm$ ].

Q Sol:- As  $G_L = \frac{\alpha I_p(x)}{h\nu}$ , where  $E = h\nu = \frac{1.24}{0.75} = 1.65 eV$ .

$$\Rightarrow G_L = \frac{0.9 \times 10^4 \times 0.05}{1.6 \times 10^{-19} \times 1.65} = 1.70 \times 10^{21} cm^{-3}s^{-1}$$

Q. Consider a Silicon Semiconductor @  $T = 300^\circ\text{K}$  in which  $N_A = 10^{16}/\text{cm}^3$  &  $N_D = 3 \times 10^{15}/\text{cm}^3$ . Calculate Thermal Equilibrium Concentration of Majority Carriers ———  $\times 10^{15}/\text{cm}^3$ !

Sol:- Since both  $N_A$  &  $N_D$  Exist  $\Rightarrow$  Compensated Semiconductor.  
Since  $N_A > N_D \Rightarrow$  p-type.

$$\therefore P_0 = \frac{N_A - N_D}{2} + \sqrt{\left(\frac{N_A - N_D}{2}\right)^2 + n_i^2}$$

$$\therefore P_0 = \frac{10^{16} - 3 \times 10^{15}}{2} + \sqrt{\left(\frac{10^{16} - 3 \times 10^{15}}{2}\right)^2 + (1.5 \times 10^{10})^2} \approx 7 \times 10^{15}/\text{cm}^3$$



Q. In a BJT of npn Transistor, Emitter is doped with Phosphorus of  $N_D = 10^{16}/\text{cm}^3$ . If Device Maintained @  $300^\circ\text{K}$ , Determine the fraction of total Electrons Still in the Donor state @  $T = 300^\circ\text{K}$ ? (Consider  $N_C = 2.8 \times 10^{19}/\text{cm}^3$ )

- a). 41%.      b). 0.41%.      c). 38%.      d). 0.38%.

Sol:- Since, 
$$\frac{n_d}{n_o + n_d} = \frac{1}{1 + \frac{N_C}{2N_D} \exp\left(\frac{E_D - E_C}{kT}\right)}$$

$$\Rightarrow \frac{n_d}{n_o + n_d} = \frac{1}{1 + \frac{2.8 \times 10^{19}}{2 \times 10^{16}} \exp\left(\frac{-0.045}{0.026}\right)} = 0.0041 = 0.41\%.$$

option (b).

Q. A MOSFET @ 300K contains an Acceptor Impurity  $N_A = 10^{16}/\text{cm}^3$ . Determine the Concentration of Donor Impurity atoms that must be added ( $\text{---} \times 10^{16}/\text{cm}^3$ ) for a Specific Application so that the silicon is n-type & Fermi level is 0.20 eV below Conduction band edge?

Sol:- For n-type (Non Compensated) As we know,  
$$E_C - E_F = kT \log_e \left| \frac{N_C}{N_D} \right| \quad [\text{for } n_0 \approx N_D]$$

Now for n-type Compensated,

$$E_C - E_F = kT \log_e \left| \frac{N_C}{N_D - N_A} \right| \Rightarrow N_D - N_A = N_C \exp \left( \frac{E_F - E_C}{kT} \right)$$

$$\Rightarrow N_D - N_A = 2.8 \times 10^{19} \exp\left[\frac{-0.20}{0.026}\right]$$

[ $\because$  we know,  
 $N_c$  for Si @ 300°K  
is  $2.8 \times 10^{19}/\text{cm}^3$ ].

$$\Rightarrow N_D - N_A = 1.24 \times 10^{16} / \text{cm}^3.$$

$$\Rightarrow N_D = 1.24 \times 10^{16} + N_A$$

$$\Rightarrow \boxed{N_D = 2.24 \times 10^{16} / \text{cm}^3.}$$